IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

cants:

R.B. Darling et al.

Attorney Docket No.: UWOTL116278

Application No.: 09/744,360

Group Art Unit: 3653

Filed:

January 22, 2001

Examiner: T.N. Nguyen

Title:

CHARGED PARTICLE BEAM DETECTION SYSTEM

RECEIVED **GROUP 3600**

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

August 15, 2003

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

- Copies of the listed patents, publications, and other information are enclosed for the Examiner's use.
- Pursuant to 37 C.F.R. § 1.97(b), this Information Disclosure Statement is being \mathbf{X} filed within three months of the filing date of the national application (other than a CPA), within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, before the mailing date of a first Office Action on the merits, or before the mailing date of a first Office Action after the filing of an RCE.

Respectfully submitted,

CHRISTENSEN O'CONNOR JOHNSON KINDNESSPLLC

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

GER:md

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INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE PROSECUTION OF THE SUBJECT APPLICATION

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Title:		CHARGED PARTICLE BEAM DETECTION SYSTEM						AL	1621
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*Examiner Initial	Cite No.								
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	 O'Morain, C., et al., "Large-Diameter Plasma Profile Monitoring System Using Faraday Cup and Langmuir Probe Arrays," Meas. Sci. Technol. 4:1484-1488, December 1993. O3 Scheidemann, A.A. et al., "Linear Dispersion Mass Spectrometer," Proceedings of the 47th American Society for Mass Spectrometry Conference on Mass Spectrometry and Allied Topics, Dallas, Texas, June 1999. 							_	
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Examiner		Date Considered							
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*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicants.

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